

J1059 U.S. PTO
10/013088



U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10013088	FILING DATE 12/07/2001	CLASS 438	SUBCLASS	GAU 2812	EXAMINER
**APPLICANTS: Wu Xiaojun;					
**CONTINUING DATA VERIFIED:					
** FOREIGN APPLICATIONS VERIFIED:					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO	
Verified and Acknowledged Examiners's initials		TI-33227 (032350.B373)			
TITLE : Method of manufacturing and structure of semiconductor device with field oxide structure					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner	
		Application Examiner	
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